

Title (en)
LASER MICROSENSOR

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Application
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Abstract (en)
[origin: EP0084086A2] In a laser microsensor, with a pulsed laser for the excitation of samples (1) and with a propagation time mass-spectrometer (4, 5) surrounding a propagation path (4), an electrode system (9) is positioned in front of the propagation time path (4), which electrode system (9) is used for the formation of an ion pulse, defined with respect to time, from the plasma produced by excitation of the sample (1) (Fig. 1). <IMAGE>

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H01J 49/14 (2006.01); **H01J 49/40** (2006.01)

CPC (source: EP)
H01J 49/164 (2013.01); **H01J 49/40** (2013.01)

Citation (search report)

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